

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of

Hitomi SAKURAI

Serial No. 10/616,732 : Group Art Unit - 2812

Filed: July 10, 2003

: Examiner: Alexander G. Ghyka

For: METHOD FOR MANUFACTURING :

A SEMICONDUCTOR DEVICE : Docket No. S004-5072

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MS AF COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

## NOTICE OF APPEAL

## S I R:

Applicant hereby appeals from the decision dated April 6, 2005 of the Primary Examiner finally rejecting claims 1-20. The items checked below are appropriate:

- 1. (X) An extension of time to respond to the final rejection was granted to August 6, 2005 for one month.
- 2. (X) A timely response to the final rejection has been filed, as provided in 841 O.G. 1411.

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MAILING CERTIFICATE ON PAGE 2

3. (X) A check in the amount \$500.00 is enclosed herewith to cover the required appeal fee. Should the check prove insufficient for any reason, authorization is hereby given to charge any such insufficiency to Deposit Account No. 01-0268.

Respectfully submitted,

ADAMS & WILKS Attorneys for Applicant

Bv:

Brice L. Adams

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## MAILING CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: MS AF, COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

DONNA RICCARDULLI

Name

Justure .

AUGUST 5, 2005

Date